

Appl. No. 09/802,693

PATENT

Amdt. dated January 26, 2004

Reply to Office Action of June 25, 2003 and Notice of Non-Compliant Amendment mailed January 21, 2004

Amendments to the Specification:

Please replace the paragraph at page 1, lines 10-12 with the following amended paragraph:

*Entered
in Amdt D*
U.S. Patent Application Serial No. 09/791,911 _____ "A Circuit Pattern
Inspection Method And Apparatus," by Takashi Hiroi, ~~et.~~ et al., filed February 22, 2001
(Attorney Docket No. 16869P-017800).